

Amendments to the Claims:

This listing of claims is provided for the Examiner's convenience. No claim amendment has been made.

Listing of Claims:

1. (Original) A method to singulate a circuit die from an integrated circuit wafer, said method comprising:

providing an integrated circuit wafer containing a circuit die;

cutting through said integrated circuit wafer by performing a single, continuous cut around the perimeter of said circuit die to thereby singulate said circuit die.

2. (Original) The method according to Claim 1 wherein said singulated circuit die comprises a non-rectangular perimeter.

3. (Original) The method according to Claim 1 wherein said singulated circuit die comprises a perimeter having rounded corners.

4. (Original) The method according to Claim 1 wherein said singulated circuit die comprises a perimeter having more than four sides.

5. (Original) The method according to Claim 1 wherein said singulated circuit die comprises a perimeter having three sides.

6. (Original) The method according to Claim 1 wherein said singulated circuit die comprises an elliptical perimeter.

7. (Original) The method according to Claim 1 wherein said singulated circuit die comprises a circular perimeter.

8. (Original) The method according to Claim 1 wherein said step of cutting through is performed using a laser.

9. (Original) The method according to Claim 1 wherein said step of cutting through is performed using an electron beam or water jet.

10. (Original) The method according to Claim 1 further comprising:
fixably mounting said singulated circuit die onto a package; and
coupling signal pins of said package to signals in said electronic circuit.

11. (Original) A method to singulate a circuit die from an integrated circuit wafer, said method comprising:

providing an integrated circuit wafer containing a circuit die;
cutting through said integrated circuit wafer by performing a single, continuous cut around the perimeter of said circuit die to thereby singulate said circuit die and wherein said singulated circuit die comprises a non-rectangular perimeter;
fixably mounting said singulated circuit die to package; and
coupling signal pins of said package to signals in said electronic circuit.

12. (Original) The method according to Claim 11 wherein said non-rectangular perimeter has rounded corners.

13. (Original) The method according to Claim 11 wherein said non-rectangular perimeter more than four sides.

14. (Original) The method according to Claim 11 wherein said non-rectangular perimeter has three sides.

15. (Original) The method according to Claim 11 wherein said non-rectangular perimeter is an ellipse.

16. (Original) The method according to Claim 11 wherein said non-rectangular perimeter is a circle.

17. (Original) The method according to Claim 11 wherein said step of cutting through is performed using a laser.

18. (Original) The method according to Claim 11 wherein said step of cutting through is performed using an electron beam or a water jet.

19. (Currently Amended) A method to singulate a circuit die from an integrated circuit wafer, said method comprising:

providing an integrated circuit wafer containing a circuit die;

providing a first cut partially cutting through said integrated circuit wafer on a first part of the perimeter of said circuit die using a focused beam apparatus; and

providing a second cut cutting through said integrated circuit wafer on a second part of said perimeter of said circuit die using a wafer saw blade apparatus to thereby singulate said circuit die[.];

wherein at least one of the first and second cut is performed by a single continuous cut around the perimeter of said circuit die.

20. (Original) An integrated circuit device comprising:

a semiconductor substrate containing an electronic circuit wherein said semiconductor substrate has a non-rectangular perimeter; and

a package comprising:

a surface to fixably mount said semiconductor substrate;

a plurality of signal pins; and

a means of coupling said signal pins to signals in said electronic circuit.

21. (Original) The device according to Claim 20 wherein said non-rectangular perimeter has rounded corners.

22. (Original) The device according to Claim 20 wherein said non-rectangular perimeter has more than four sides.

23. (Original) The device according to Claim 20 wherein said non-rectangular perimeter has three sides.

24. (Original) The device according to Claim 20 wherein said non-rectangular perimeter is an ellipse.

25. (Original) The device according to Claim 20 wherein said non-rectangular perimeter is an "L" shape, an "H" shape, a "T" shape, or a curved shape.